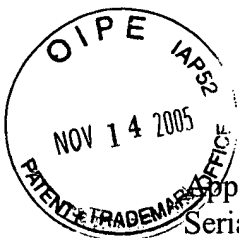


IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Koujiro Kameyama et al.

Art Unit : 2826

Serial No. : 10/812,454

Examiner : Johannes P. Mondt

Filed : March 30, 2004

Title : OPTICAL SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING SAME

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF AUGUST 11, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 9, 2005

Date of Deposit

Paula T. Romeo

Signature

PAULA T. ROMEO

Typed or Printed Name of Person Signing Certificate